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Selected Papers from the 5th International Conference on Mechanics and Mechatronics Research (ICMMR 2018)

Guest Editor:

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Deadline for manuscript submissions:

closed (20 November 2018)

Message from the Guest Editor

Dear Colleagues,

This Special Issue will publish selected papers from the 2018 5th International Conference on Mechanics and Mechatronics Research (ICMMR 2018), 19 July to 21 July, 2018, in Tokyo, Japan. We encourage contributions on significant and original works of Machanical Engineering and Mechatronic Engineering.

- Design and Manufacturing
- Mechatronics
- Micro-Machining
- Nano-Technology
- Advanced Manufacturing
- Sensors and Actuators and Networks
- Robotics, Mobile Platforms, Unmanned Vehicles
- Micro Mechatronics
- Mechatronics in Energy Systems
- Fault detection and Diagnosis in Mechatronics Systems
- Applications in Systems and Engineering

Papers attracting most interests in the conference, or that provide novel contributions, have been selected for publication in *Micromachines*. These papers will be peer-reviewed for validation of research results, developments and applications.

Prof. Kazuo Umemura

Guest Editor

Specialsue











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Message from the Editor-in-Chief

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